
Research on Enhanced Detuned-Loading Effect in Integrated Two-Section DFB Lasers with High Modulation Bandwidth

[Yunshan Zhang](#) , [Hongming Gu](#) , Guolong Ma , Shijian Guan , [Tao Fang](#) , [Xiangfei Chen](#) *

Posted Date: 17 October 2023

doi: 10.20944/preprints202310.1032.v1

Keywords: distributed feedback (DFB) semiconductor lasers; modulation bandwidth enhancement; detuned-loading effect; reconstruction-equivalent-chirp (REC) technique



Preprints.org is a free multidiscipline platform providing preprint service that is dedicated to making early versions of research outputs permanently available and citable. Preprints posted at Preprints.org appear in Web of Science, Crossref, Google Scholar, Scilit, Europe PMC.

Copyright: This is an open access article distributed under the Creative Commons Attribution License which permits unrestricted use, distribution, and reproduction in any medium, provided the original work is properly cited.

Article

Research on Enhanced Detuned-Loading Effect in Integrated Two-Section DFB Lasers with High Modulation Bandwidth

Yunshan Zhang ¹, Hongming Gu ¹, Guolong Ma ¹, Shijian Guan ², Tao Fang ² and Xiangfei Chen ^{2,*}

¹ College of Electronic and Optical Engineering and College of Flexible Electronics (Future Technology), Nanjing University of Posts and Telecommunications; yszhang@njupt.edu.cn, 973304185@qq.com, 1225330056@qq.com

² College of Engineering and Applied Sciences, Nanjing University; 965872540@qq.com, fangt@nju.edu.cn

* Correspondence: chenxf@nju.edu.cn

Abstract: A novel high-speed directly modulated two-section distributed feedback (TS-DFB) semiconductor laser based on the detuned-loading effect is proposed and simulated. Grating structure is designed by reconstruction-equivalent-chirp (REC) technique. A π phase-shift is introduced into the reflection grating, which can provide a narrow-band reflection region with a sharp falling slope on both sides of the reflection spectrum, thus enhancing the detuned-loading effect. Owing to its unique dual-falling-edges structure the bandwidth can be improved even when the lasing wavelength shifts beyond the left falling edge due to thermal effect in actual test, in which condition the detuned-loading effect can be used twice, which greatly improves the yield. The modulation bandwidth is increased from 17.5 GHz for a single DFB laser to around 24 GHz when the lasing wavelength is located on the left falling edge of the TS-DFB laser based on detuned-loading effect, and can be increased to 22 GHz for the right side. An eight-channel laser array with precise wavelength spacing is investigated, with side mode suppression ratio (SMSR) > 36dB. Besides, TS-DFB lasers with uniform reflection grating are studied and simulated result shows that modulation characteristic is far inferior to the laser with a phase-shifted grating reflector.

Keywords: distributed feedback (DFB) semiconductor lasers; modulation bandwidth enhancement; detuned-loading effect; reconstruction-equivalent-chirp (REC) technique

1. Introduction

With the explosive increasing demand for network traffic, a reliable high-speed light source enabling high-capacity optical network communication is urgently needed. Directly modulated semiconductor laser (DML) is considered as an ideal light source and has been widely applied in optical data transmission systems for its high energy efficiency, low cost and compact size.

Relaxation oscillation frequency is the main factor limiting the transfer rate and capacity of DML. To increase the relaxation oscillation frequency, shortening the cavity length [1–3] and the buried heterostructure (BH) [4–6] are always applied in the laser structure. Buried heterostructures can reduce the leakage current, restrict the current and light field and have better threshold characteristics and slope efficiency. Shortening the cavity length can reduce the volume of the active region and improve the modulation rate of the laser. However, less feedback in the short cavity will lead to higher threshold gain and the complex fabrication process of buried heterostructures will greatly increase the cost.

Many other methods are also proposed to increase the modulation bandwidth. Such as detuned-loading effect [7–11], optical injection locking [12–14] and photon-photon resonance [15–18]. However, most of these schemes need to use multi-segment structure lasers, so the butt-joint growth process is unavoidable and the integration between the active and passive region greatly increases the difficulty and cost of manufacture.

In this paper, we demonstrate a novel high-speed directly modulated two-section distributed feedback (TS-DFB) semiconductor laser based on detuned-loading effect. The TS-DFB laser is designed by the reconstruction-equivalent-chirp (REC) technique [19,20]. Using REC technique, the production standard can be reduced to the micron level, which would greatly reduce the manufacturing cost. This device consists of two sections: DFB section and grating reflector (GR) section. These two sections share the same wafer structure, avoiding the complex butt-joint growth technology. Through tuning the sampling periods of the sampled Bragg gratings (SBGs), the frequency detuning between these two sections can be achieved. When the lasing wavelength is located on the falling edge of the reflection spectrum of GR section, the detuned-loading effect will be introduced which can greatly enhance the modulation bandwidth.

When a π phase-shift is introduced into the middle of GR section, a symmetrical hollow will appear in the center of the reflection spectrum. As that the detuned-loading effect can be achieved twice during the wavelength tuning. Furthermore, the introduction of phase shift can effectively shorten the length of chip due to the enhancement of detuned-loading effect. Owing to its unique dual-falling-edges structure the bandwidth can be improved even when the lasing wavelength shifts beyond the left falling edge due to thermal effect in actual test, in which condition the detuned-loading effect can be used twice, which greatly improves the yield. the performance is much better when the lasing wavelength is located on the left falling edge. In other words, a steeper falling slope can provide the enhanced detuned-loading effect on the improvement of modulation bandwidth and a better working characteristic for TS-DFB lasers.

Based on the detuned-loading effect, the modulation bandwidth of the TS-DFB laser is increased from 17.5 GHz for a single DFB laser to around 24 GHz when the lasing wavelength is located on the left falling edge and can be increased to 22 GHz when the lasing wavelength is located on the right side. Clear eye diagrams can be observed when the laser is modulated by 25 Gb/s and 30 Gb/s non-return-to-zero (NRZ) signal. An eight-channel laser array with precise wavelength spacing is investigated, with SMSR > 36 dB. For lasers with no phase-shift in the GR section, the lasing wavelength can easily fall outside the falling edge of the reflection spectrum during the tuning in which case the detuned-loading effect will not work. Moreover, its falling edge is smoother and the maximum modulation bandwidth is only 22 GHz. The modulation characteristic of the TS-DFB laser with uniform GR section is far inferior to the laser with a phase-shifted GR section.

2. Principle and Design

2.1. Principle of the REC technique

In order to meet the growing demand for the laser performance, many gratings with sophisticated structures have been applied. The REC technique using sampled grating is proposed, where only conventional holographic exposure and micrometer-level photolithography technique are required in the fabrication. In this method, complex grating structures can be quickly and precisely achieved by simply covering the mask above the seed grating and proceed with photolithography. The principle will be presented briefly in the following.

For the SBGs, the index modulation change $\Delta n(z)$ can be described by:

$$\Delta n(z) = \frac{1}{2} s(z) \exp\left(j \frac{2\pi z}{\Lambda}\right) + \text{c.c.} \quad (1)$$

where $s(z)$ is the periodic function of a sampling modulation and Λ is the period of seed grating. According to the Fourier series expansion, $s(z)$ can be written as:

$$s(z) = \sum_m F_m \exp\left(j \frac{2m\pi z}{P}\right) \quad (2)$$

where P is the sampling period, F_m is the Fourier coefficient corresponding to the m th-order channel of the SBG. When substituting (2) into (1), we can get:

$$\Delta n(z) = \sum_m \frac{1}{2} F_m \exp \left[j \left(\frac{2\pi z}{\Lambda} + \frac{2m\pi z}{P} \right) \right] + \text{c.c.} \quad (3)$$

From (3), we find that the SBG is actually a super-position of many subgratings with different grating periods. The m th equivalent grating period is given by:

$$\Lambda_m = \frac{P\Lambda}{P+m\Lambda} \quad (4)$$

When introducing a sampling period change ΔP to $s(z)$ at z_0 , the index modulation of the m th-order subgrating will be changed as:

$$\Delta n_m(z) = \begin{cases} F_m \exp \left(j \frac{2\pi z}{\Lambda} + j \frac{2m\pi z}{P} \right) + \text{c.c.} & z \leq z_0 \\ F_m \exp \left(j \frac{2\pi z}{\Lambda} + j \frac{2m\pi z}{P} - j\theta \right) + \text{c.c.} & z > z_0 \end{cases} \quad (5)$$

where the phase θ is obtained as:

$$\theta = 2m\pi \frac{\Delta P}{P} \quad (6)$$

If $m \neq 0$, an equivalent phase shift (EPS) can be achieved. According to (4) and (5), we can see that the SBG has multiple channels. The lasing wavelength and spectrum spacing of each channel are mainly determined by the sampling period P . In the practical design, by choosing a proper P , we can ensure that only the +1st order channel is located within the wavelength range where the material has sufficient gain and all other channels are located outside the gain region. By changing the sampling period at equal intervals, a laser array can be fabricated.

2.2. Principle of detuned-loading effect

The principle of detuned-loading effect of the DML is illustrated as follows. This effect occurs on the falling edge of the Bragg reflector mirror of DBR lasers (Distributed Bragg Reflector Lasers) or DR lasers (Distributed Reflector Lasers). In Figure 1. (a), '0' represents the lasing wavelength position at low injection current, '1' represents the lasing wavelength position at high injection current. In Figure 1. (b), as the gain section is modulated, the detuning between two sections sets the main mode on the long wavelength flank of the Bragg peak of grating reflector, while the frequency up-chirp of the TS-DFB laser due to changes in refractive index under direct modulation will shift the main mode closer to the Bragg peak of GR section, in which condition the chirp of DMLs is translated into dynamic changes in the penetration depth and the loss of the DBR mirror. When chirp pushes the lasing wavelength to shorter wavelength where the mirror has a higher reflection, mirror loss is reduced. Reduction of loss will increase effective differential gain and this can enhance the speed of DMLs beyond the limit of the material properties.

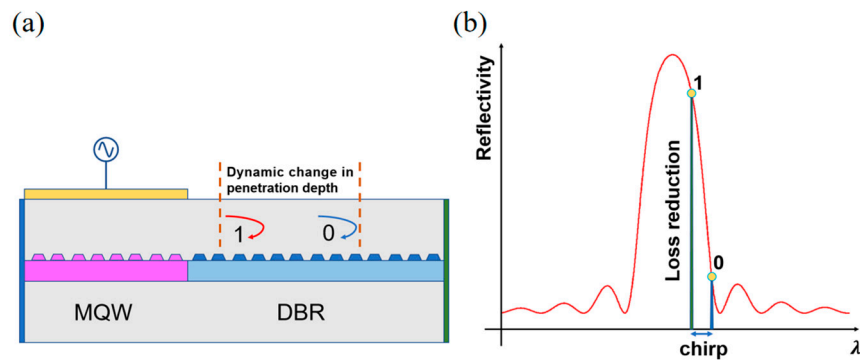


Figure 1. The principle of detuned-loading effect in the TS-DFB laser.

2.3. Principle of the Simulation

The basic mode used in this paper is time-domain dynamic model (TDDM) [21–23]. In this mode, the laser cavity is uniformly divided into several subsections. During the process of light transmission, each subsection has its own independent parameters, such as grating coupling intensity, carrier density, photon density, gain, loss, refractive index, etc. If the division is detailed enough, namely, the length of the microelement is small enough, each subsection can be considered uniform. According to the coupling wave theory, the optic field within the laser can be seen as a superposition of forward wave $F(z, t)$ and backward wave $R(z, t)$:

$$E(x, y, z, t) = \varphi(x, y) [F(z, t)e^{-i\beta_0 z} + R(z, t)e^{i\beta_0 z}] e^{i\omega_0 t} \quad (7)$$

where ω_0 is the reference frequency corresponding to the Bragg wavelength, β_0 is the propagation constant at the Bragg wavelength. $\varphi(x, y)$ is the distribution function of the mode in the waveguide.

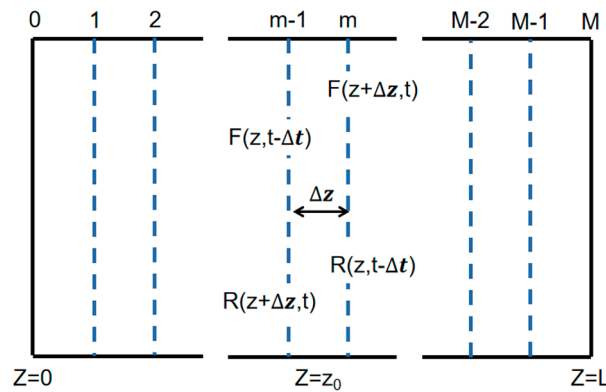


Figure 2. The schematic of time-domain dynamic model.

The coupled wave equations of forward wave $F(z, t)$ and backward wave $R(z, t)$ are derived from Maxwell's equations and can be written as:

$$\begin{aligned} \frac{1}{c_g} \frac{dF(z, t)}{dt} + \frac{dF(z, t)}{dz} &= (G - i\delta)F(z, t) + ikR(z, t) + S_f(z, t) \\ \frac{1}{c_g} \frac{dR(z, t)}{dt} - \frac{dR(z, t)}{dz} &= (G - i\delta)R(z, t) + ik^*F(z, t) + S_r(z, t) \end{aligned} \quad (8)$$

where k is the coupling coefficient of the grating in the waveguide, describing the coupling of forward and backward waves in the grating. G and δ are the mode gain and detuning factor, respectively. $S_f(z, t)$ and $S_r(z, t)$ characterize the spontaneous emission noise within the waveguide, providing incentives for oscillation. When light is transmitted, the gain obtained can be written as:

$$G(z, t) = \frac{\Gamma g \ln\left(\frac{N(z, t)}{N_0}\right)}{2(1 + \varepsilon P(z, t))} - \frac{\alpha(z, t)}{2} \quad (9)$$

where g is the gain coefficient, N_0 is transparency carrier density, $\alpha(z, t)$ is the internal loss caused by waveguide scattering and quantum-wells absorption. $P(z, t)$ represents the photon density within the cavity, which can be written as:

$$P(z, t) = |F(z, t)|^2 + |R(z, t)|^2 \quad (10)$$

The parameter δ in Equation (8) is detuning factor due to the change of the refractive index in waveguide, representing the degree to which the lasing center wavelength deviates from the Bragg condition, and can be written as:

$$\delta = \frac{\omega_0}{c} (n_{eff,0} + \Delta n) - \frac{\pi}{\Lambda} \quad (11)$$

where $n_{eff,0}$ is the effective refractive index at transparency carrier density, Λ is the period of seed grating and Δn is the refractive index change caused by current injection, which is given by:

$$\Delta n = -\frac{\lambda_0}{4\pi} \Gamma \alpha_m \ln\left(\frac{N(z, t)}{N_0}\right) \quad (12)$$

where α_m is the linewidth enhancement factor.

When current is injected into the laser, the internal carrier and photon density will change. Substituting those parameters into the time-domain carrier rate equation, the time-dependent carrier density rate equation changing with time will be obtained:

$$\frac{dN}{dt} = \frac{\eta_i J}{ed_{act}} - AN - BN^2 - CN^3 - \frac{c_g g \ln\left(\frac{N(z, t)}{N_0}\right)}{(1 + \varepsilon P(z, t))} \quad (13)$$

where J is current density, d_{act} is the thickness of active layer, A is the linear recombination coefficient, B is the spontaneous recombination coefficient and C is the Auger recombination coefficient.

The boundary conditions of the forward light field and the backward light field at the interface can be written as:

$$\begin{aligned} F(z=0) &= r_L R(z=0) \\ R(z=L) &= r_R F(z=L) \end{aligned} \quad (14)$$

where r_L and r_R are the reflectivity of the front and rear surfaces of the laser, respectively. Then the output power of the laser at surface can be written as:

$$\begin{aligned} P_{front} &= hv(wd_{act}v_g/\Gamma) |(1-r_R)F(L,t)|^2 \\ P_{back} &= hv(wd_{act}v_g/\Gamma) |(1-r_L)R(0,t)|^2 \end{aligned} \quad (15)$$

where h is Planck's constant, ν is the reference frequency, and w is the waveguide width.

2.4. The design of TS-DFB laser

The epitaxial structure of the chip under production is shown in Figure 3. (a), where traditional metal-organic chemical vapor deposition (MOCVD) growth is used. During the first epitaxial growth, the N-InP buffer, lower separate-confinement-heterostructure (SCH) layer, AlGaInAs multi-quantum wells (MQW) active region, upper SCH layer and grating layer are grown on the N-InP substrate in turn. The SBG is achieved by holographic exposure combined with photolithography. Then, the P-InP cladding layer, P-InGaAsP etch stop layer and P-InP ridge waveguide (RWG) are fabricated. Finally, in order to suppress the Fabry-Perot modes of the lasers, AR coatings with reflectivity less than 1% are deposited on both facets.

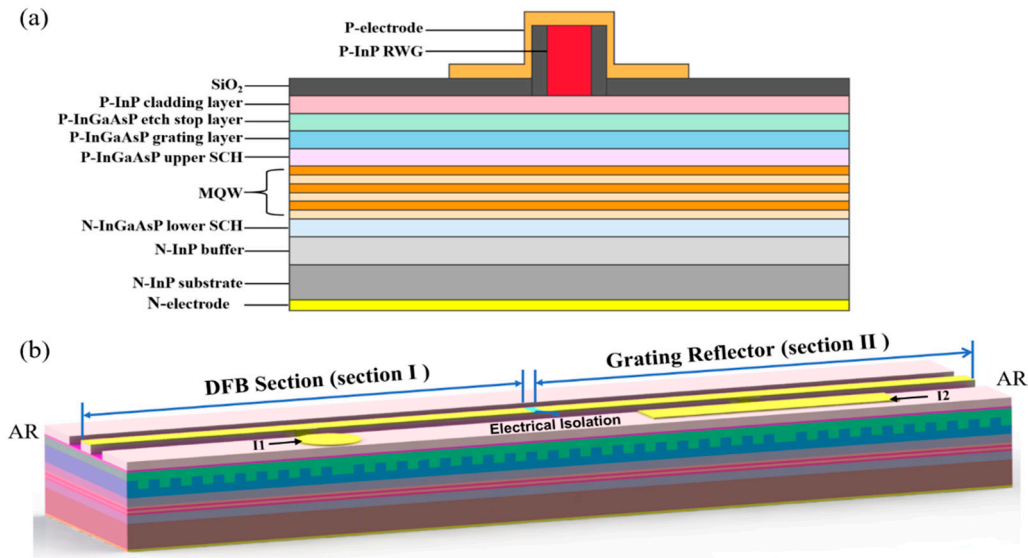


Figure 3. (a) Epitaxial structure of chip under production; (b) Schematic of the TS-DFB laser.

The schematic of the proposed laser structure is depicted in Figure 3. (b). The laser is composed of two sections, which can be seen as active DFB section and grating reflection section. For convenience, we will refer to these two regions as section I and section II in the following parts. They can be injected into different current I_1 and I_2 , respectively. These two sections share the same seed grating period but slightly different sampling periods. By setting different sampling periods in each section, wavelength detuning with high accuracy can be achieved. There will be no current crosstalk phenomenon due to electrical isolation added in the middle of these two sections.

The structure schematic of the SBG in the TS-DFB laser is shown in Figure 4. (a). The sampling structure is formed by a conventional holographic exposure combined with photolithography. In our design, Section I works as a lasing section where an abrupt π phase-shift is introduced in the middle of the grating structure to guarantee a single-longitudinal-mode (SLM) operation. Section II works as a grating reflector to provide Section I with high reflectivity but no laser oscillation will happen in this section. A π phase-shift is introduced in the middle of section II to provide a sharp falling slope and an extra falling edge. The phase is continuous across the interface between the two adjacent sections and no additional phase shift is introduced. Both facets are anti-reflection (AR) coated to avoid the influence of random phase. The transfer matrix method (TMM) [23,24] and time-domain dynamic model (TDDM) are utilized for simulation. The passive spectra of reflection and transmission are simulated by TMM model, the small signal curve and eye diagram are simulated based on the TDDM model. Parameters used in the simulation are listed in Table 1. Some of these parameters are derived from previously fabricated epitaxial wafers and others are obtained from reference [21], such as Bimolecular recombination coefficient and Auger recombination coefficient.

Table 1. Parameters used in the simulation.

Parameter	Symbol	Value
Seed grating period (nm)	Λ_0	256.71
Sampling period of DFB section (μm)	P1	4.189
Length of DFB section (μm)	L1	400
Length of Grating reflector (μm)	L2	400
Active layer width (μm)	Wa	2
Active layer thickness (μm)	da	48
Effective refractive index	neff	3.204
Group refractive index	ng	3.6
Linewidth enhancement factor	α_h	2

Gain coefficient (cm^{-1})	g	1100
Internal loss (cm^{-1})	α	10
Optical confinement factor	Γ	0.1
Monomolecular recombination coefficient (10^9 s^{-1})	A	1
Bimolecular recombination coefficient ($10^{-10} \text{ cm}^3 \text{ s}^{-1}$)	B	1
Auger recombination coefficient ($10^{-29} \text{ cm}^6 \text{ s}^{-1}$)	C	7.5
Transparency carrier density (10^{24} m^{-3})	N_{tr}	1
Nonlinear gain saturation coefficient (10^{-23} m^{-3})	ε	4

Figure 4. (b) plots the transmission spectrum of section I and reflection spectrum of section II. Due to the introduction of a π phase-shift in the center of section II, we can clearly observe a zero point in the middle of reflection spectrum. As that when the lasing mode in section I is located on both falling edge of the reflection spectrum in section II, the detuned-loading effect can be achieved respectively. Moreover, due to the introduction of the π phase-shift in section II, the width of falling edge is narrowed and the slope is higher.

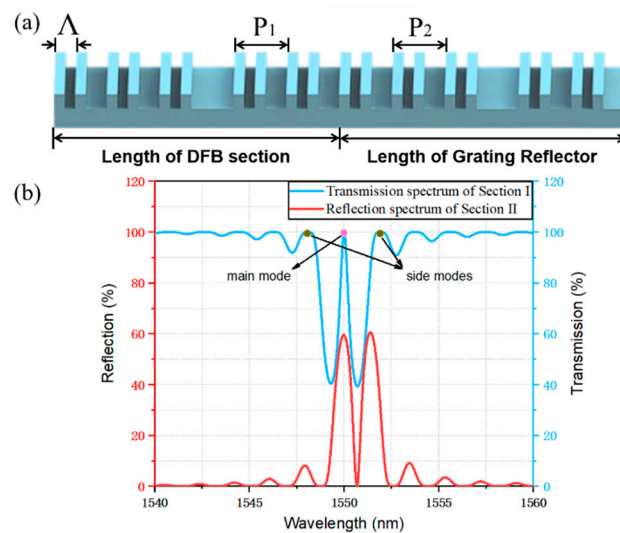


Figure 4. (a) Schematic of the SBG in the TS-DFB laser; (b) Calculated transmission and reflection spectra of the SBG in different sections.

3. Simulation Results

To investigate the enhancement of the detuned-loading effect in this structure and prevent the grating reflector from emitting light due to excessive current injection, the current injected into section II is set to 0 mA. By changing the sampling period to place lasing wavelength at different positions of the falling flank, the variation of its modulation bandwidth is studied. We divide the left and right falling edge of the reflection spectrum into four parts spaced by their width, and name their endpoints as positions A, B, C, D, and E respectively, to study the working characteristics when lasing wavelengths falling at different positions.

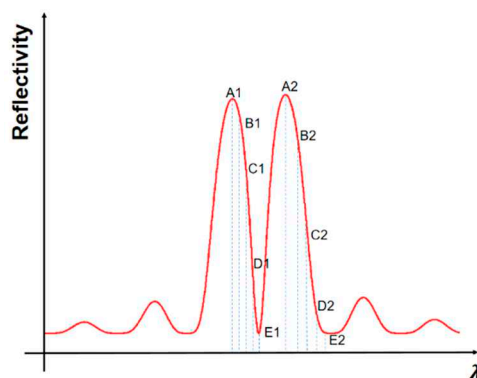


Figure 5. Schematic diagram of different operating wavelength positions.

Figure 6. (a) and (b) plot the small-signal modulation response curves when the lasing wavelength is located at corresponding positions of the left and right falling edges when injected current in section I is 100 mA. The black dash line represents that the value of the small-signal modulation response is -3 dB. When the lasing wavelength is located on the left falling edge of the reflection spectrum, the reflection spectrum becomes steeper as the increase of the penetration depth into the grating reflector. The modulation bandwidth increases from 17.8 GHz to 24 GHz, and the relaxation oscillation frequency can be enhanced from 8.6 GHz to 13 GHz. When the lasing wavelength is located on the right side, the modulation bandwidth increases from 17.6 GHz to 22 GHz, and the relaxation oscillation frequency varies from 8.4 GHz to 11 GHz.

It can be seen that in our structure, the detuned-loading effect can work when the lasing wavelength locates on both falling edges of the reflection spectrum, which is a prominent advantage over those TS-DFB lasers with uniform GR-section. Because there is no need to worry about the lasing wavelength drifting out of the reflection spectrum caused by Joule heating effect in the actual test. The left falling edge has a steeper slope, resulting in larger relaxation oscillation frequency and modulation bandwidth at different positions compared with those corresponding results when lasing wavelength located on the right side.

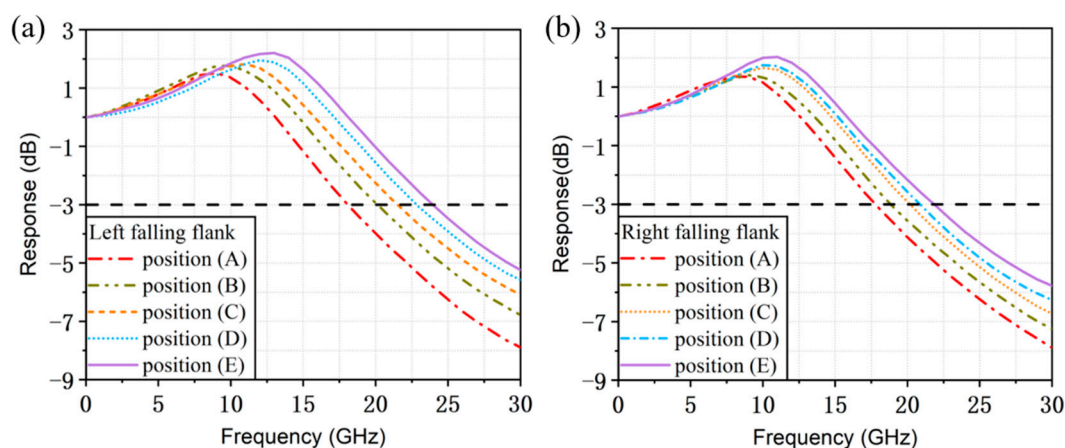


Figure 6. Small signal intensity modulation response for different positions at: (a) the left falling flank ; (b) the right falling flank when I_1 is 100 mA.

In addition, we study the output characteristics when the lasing wavelength locates on different positions of both falling edges. With the increase of the mirror loss of the grating reflector, the output power of the left facet decreases gradually. The output power varies from 42 mW to 37 mW for the left flank and decreases from 40.8 mW to 31.1 mW for the right flank when the injection current I_1 is 100 mA. It can be found that the output power of the right side is smaller than that of the left side and this can be explained as followed. Due to the introduction of the π phase-shift in the middle of

section II, the left falling flank is steeper and the width is narrower than the right. Therefore, the reflectivity of the corresponding position on the right falling edge is smaller.

Comparing Figure 6 and Figure 7, we can find that the 3-dB modulation bandwidth can be enhanced with the increase of the mirror loss while the output power of the facet would be reduced. From the results of the simulated modulation bandwidth and the output power, the performance is much better when the lasing wavelength is located on the left falling edge. In other words, a steeper falling slope can provide the enhanced detuned-loading effect on the improvement of modulation bandwidth and a better working characteristic for TS-DFB lasers.

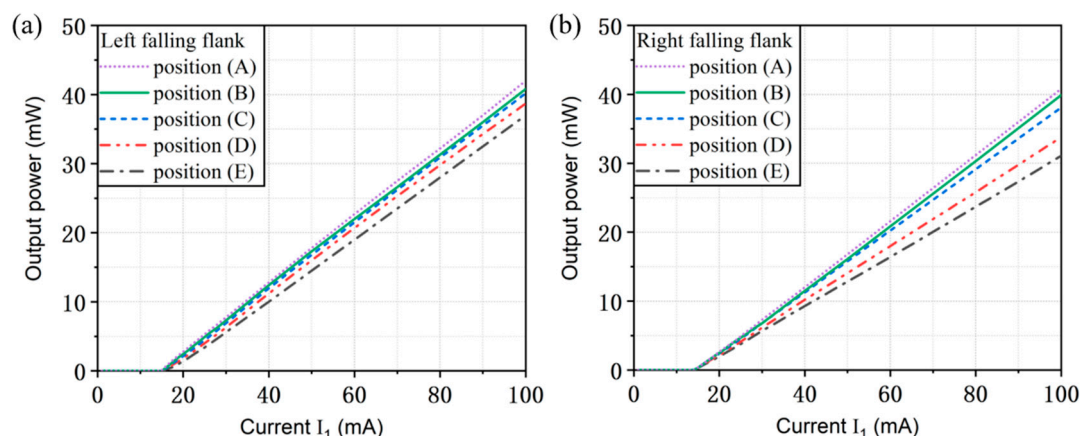


Figure 7. Light-current characteristics for different positions at: (a) the left falling flank; (b) the right falling flank.

The comparative analyses of simulation results when the lasing wavelength falls on the both falling flanks are shown in Figure 8. It can be seen that as the detuning between the lasing wavelength and the Bragg reflection peak increases, the modulation bandwidth gradually increases and the output power continuously decreases. At the same time, when the lasing wavelength falls on the left falling flank with a higher slope efficiency, the improvement of modulation bandwidth is higher and the result is much superior to the right side. The steeper slope on the left side contributes to greater change in the reflectivity difference of the Bragg reflector under equal blue-shift chirp caused by current injection, resulting in stronger detuned-loading effect. When the lasing wavelength falls at position A on both sides of the Bragg reflection spectrum, the results of simulated relaxation oscillation frequency and modulation bandwidth are similar to the one-section DFB laser (OS-DFB), where its modulation characteristics have not been effectively improved and even deteriorated. This is because the thermal effect is not taken into account during the simulation, current injection can only reduce the effective refractive index of the material, thus the lasing wavelength will blue shift to the rising edge of the reflection spectrum in which case detuned-loading effect does not work.

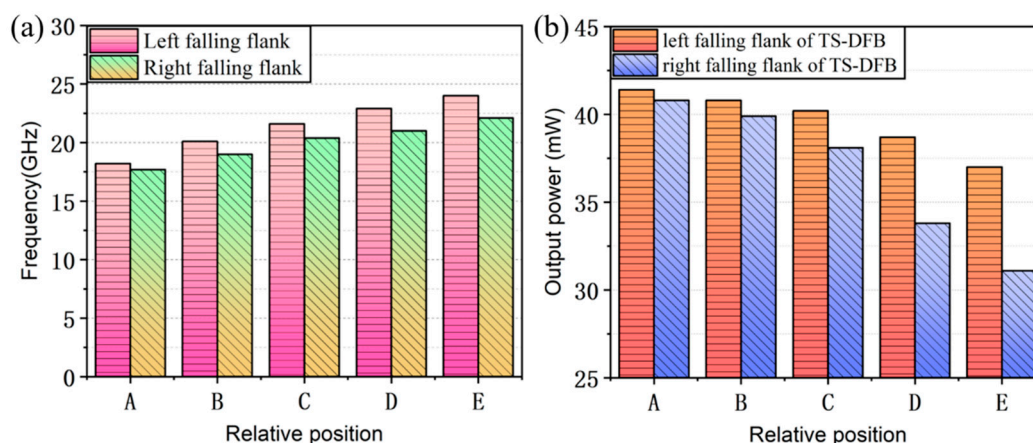


Figure 8. (a) Comparison of 3-dB modulation bandwidth between the left and right falling flank; (b) Comparison of facet output power between the left and right falling flank.

The simulated lasing spectrum is shown in Figure 9. The TS-DFB laser maintains SLM operation and the side mode suppression ratio is larger than 42 dB due to the introduction of the π phase-shift in the middle of section I .

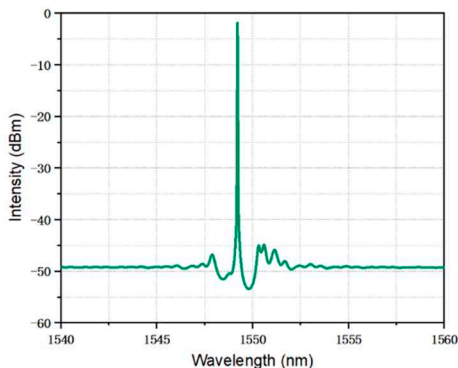


Figure 9. Lasing spectrum of the TS-DFB laser when the injection current is 100 mA.

For comparison, the response characteristic of the conventional OS-DFB laser with a cavity length of 400 μm is also given in Figure 10. (a). When the bias current of active DFB laser is 100 mA, the 3-dB modulation bandwidth of the OS-DFB laser is only about 17.5 GHz, while the maximum 3-dB modulation bandwidth of the TS-DFB laser is 24 GHz and 22 GHz when the lasing wavelength is located on the left and right falling flank respectively, where the increase of 6.5 GHz in modulation bandwidth has been achieved. Figure 10. (b) plots the simulated light-current characteristics of the TS-DFB laser and the OS-DFB laser. Apparently, the incorporation of the grating reflector can greatly improve the working performance of the laser characterized by reducing threshold current and improving the output efficiency. The threshold current of the TS-DFB laser reduces to 17 mA. When the injection current I_1 is 100 mA, the maximum output power is 42 mW and the slope efficiency is increased to 0.506 mW/mA. Compared with the conventional OS-DFB laser, the threshold current is decreased by 7 mA and the output power is increased by 18 mW.

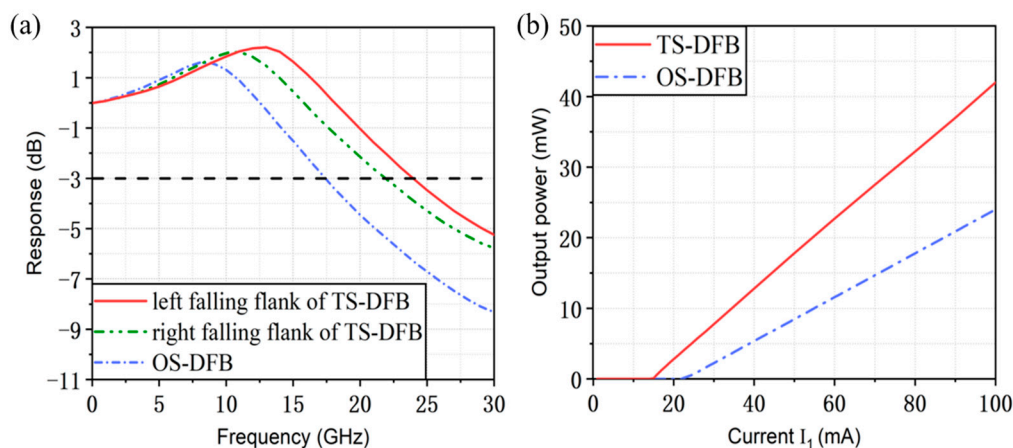


Figure 10. (a) Optimal response curves for the left and right falling edge of the TS-DFB laser and the OS-DFB laser when I_1 is set to 100 mA; (b) Simulated light-current characteristics of the TS-DFB laser and OS-DFB laser.

Current injection increases carrier density and this will decrease the refractive index of the material. The transmission spectrum of the DFB section will be blue-shifted with a decreased refractive index when the current is injected into section I . Thus, when the lasing wavelength is designed to locate on the position with lowest reflectivity, the actual wavelength will drift to the

position with higher reflectivity. This can explain why the output power of the laser at position E is still higher than that of the conventional OS-DFB laser.

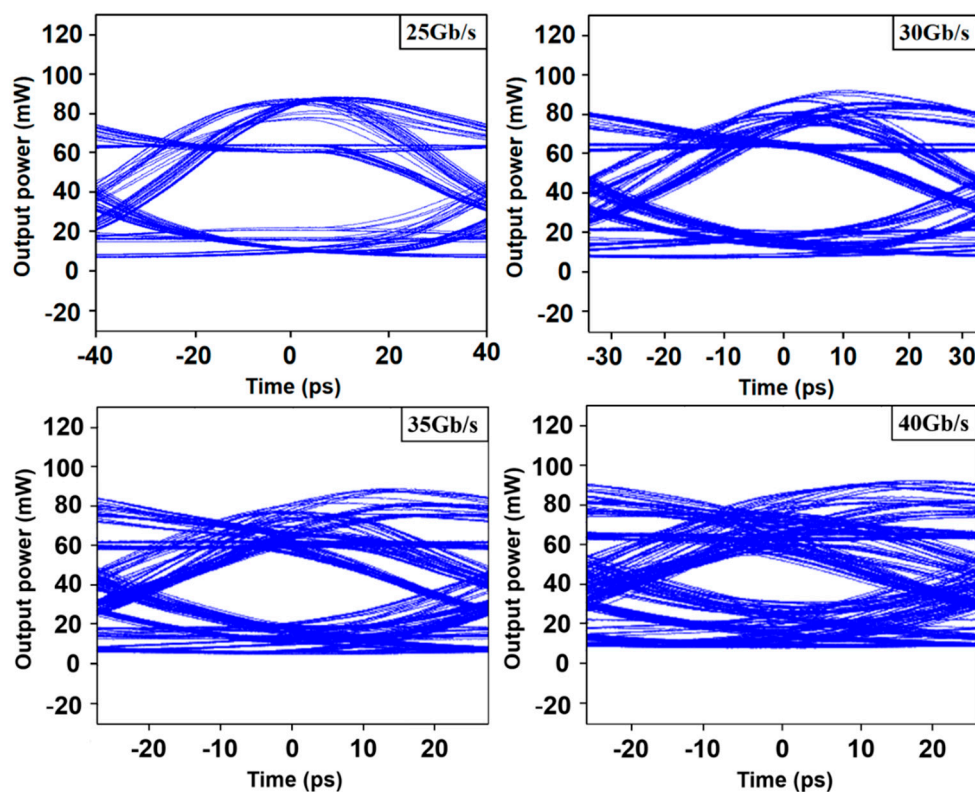


Figure 11. Eye diagrams of the laser modulated at 25 Gb/s, 30 Gb/s, 35 Gb/s and 40 Gb/s, respectively.

When the lasing wavelength is located on position D, where the modulation bandwidth is around 22 GHz, NRZ modulation is performed. The modulation rates are 25 Gb/s, 30 Gb/s, 35 Gb/s, and 40 Gb/s, respectively. The bias current is set to 100 mA and the modulation amplitude is 100 mA. Clearly, the eyes of the 25 Gb/s and 30 Gb/s are all well opened. However, due to the limitation of modulation bandwidth the result of 40 Gb/s eye diagram is not ideal. In our simulation, the current injected into section II is 0 mA so the opening of the eye diagram is relatively limited. But according to previous testing experience, the opening would be greatly improved after current injection in section II.

According to the REC theory discussed above, an eight-channel TS-DFB laser array with the wavelength around 1550 nm has been investigated. The simulated spectra of the laser array when the injection current I_1 is 100 mA is presented in Figure 12. (a). The lasing wavelength of the eight channels varies from 1547.7 nm to 1553.45 nm and the minimum SMSR of the lasers is 36.21 dB. A good SLM operation can be achieved for all those eight channel lasers. The zeroth Bragg wavelength is set to 1645 nm which is far away from the gain spectrum and no zeroth lasing will be observed in the spectrum for any injection current which ensures that only +1st sampling wavelength oscillates in the laser. In Figure 12. (b), we perform a linear fitting of the lasing wavelength. The slope efficiency of fitting curve is 0.783 nm/count. The wavelength spacing of the laser array is designed as 0.8 nm which is close to the simulation result. The wavelength residual of each laser channel can also be calculated after the linear fitting. According to the calculation, the minimum wavelength residual is 0.035 nm.

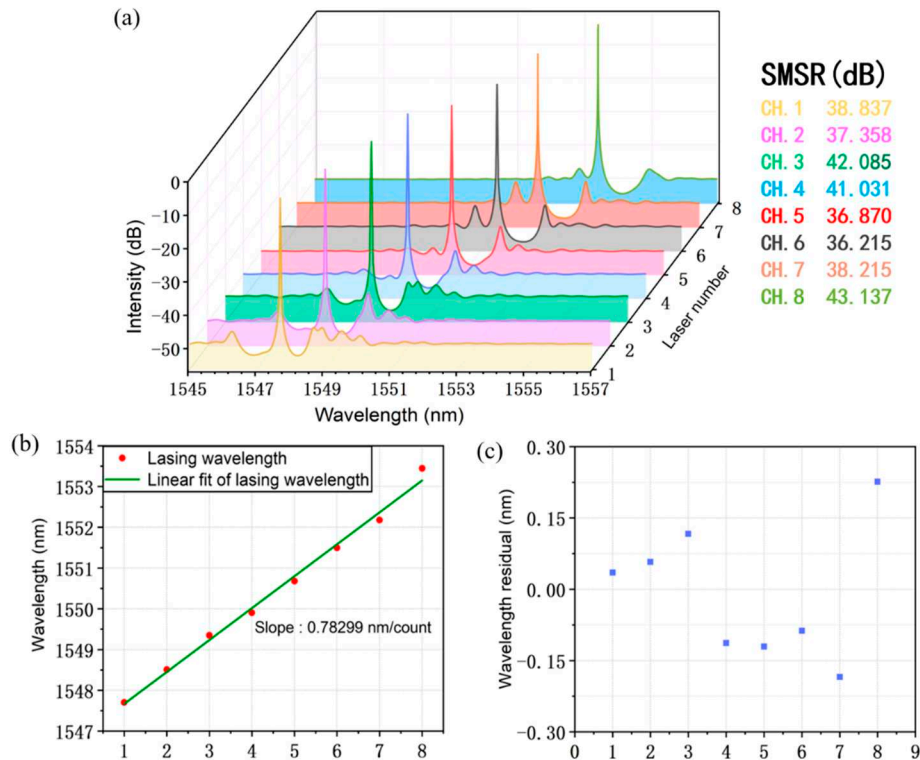


Figure 12. (a) Simulated lasing spectra of eight-channel TS-DFB laser array when I_1 is 100 mA. The table listed on the right shows the SMSR of each channel; (b) The corresponding lasing wavelengths of the laser array (red dots). The green line is the linear fitting line of the wavelengths; (c) Wavelength residuals after the linear fitting.

In addition, the effect of detuned-loading effect on modulation bandwidth enhancement in TS-DFB lasers with uniform GR section has been investigated. Parameters used in the simulation are exactly the same as those listed in Table 1 and the only difference between these two structures is that there is no phase-shift introduced in the grating reflector. As can be seen from the reflection spectrum in Figure 13, the slope of the falling edge is smoother. Since there is no phase shift is introduced, no hollows could be seen in the center of the reflection spectrum, and the reflectivity of its peak will be higher.

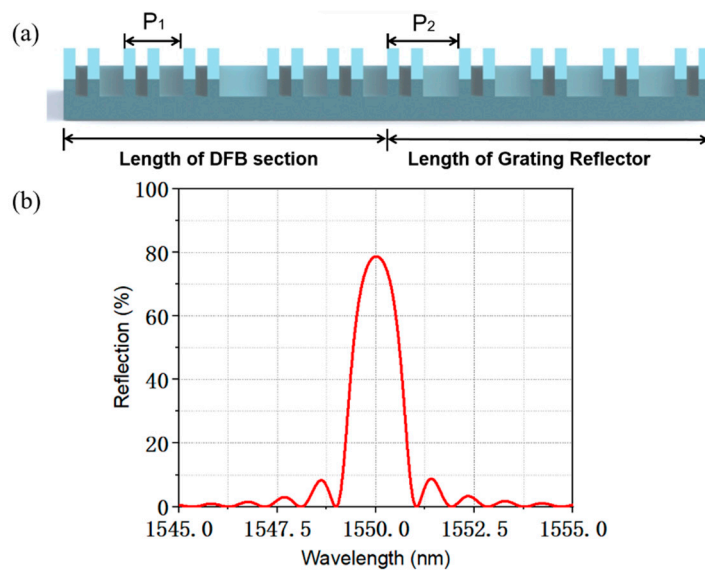


Figure 13. (a) Schematic of the SBG in the TS-DFB laser with uniform section II; (b) Calculated reflection spectrum of section II.

The small-signal modulation response curves for 100 mA current injected in section I when the lasing wavelength located at different positions of the falling flank is given in Figure 14. (a). With the increase of mirror loss of the grating reflector, the 3-dB modulation bandwidth can be increased from the initial 17.5 GHz to 22 GHz, i.e., the modulation bandwidth is increased by 4.5 GHz. However, when comparing this structure with the previously mentioned, we will find that the bandwidth improvement of the detuned-loading effect in the TS-DFB lasers with uniform grating reflector is far inferior to the laser with π phase-shift in the grating reflector. Moreover, in this structure the detuned-loading effect will not act when the lasing wavelength shifts outside the falling edge of the reflection spectrum. For lasers with phase-shift in the grating reflector, the detuned-loading effect is not only stronger, but also owing to its unique dual falling edge structure the bandwidth can be improved even when the lasing wavelength shifts beyond the left falling edge due to thermal effects.

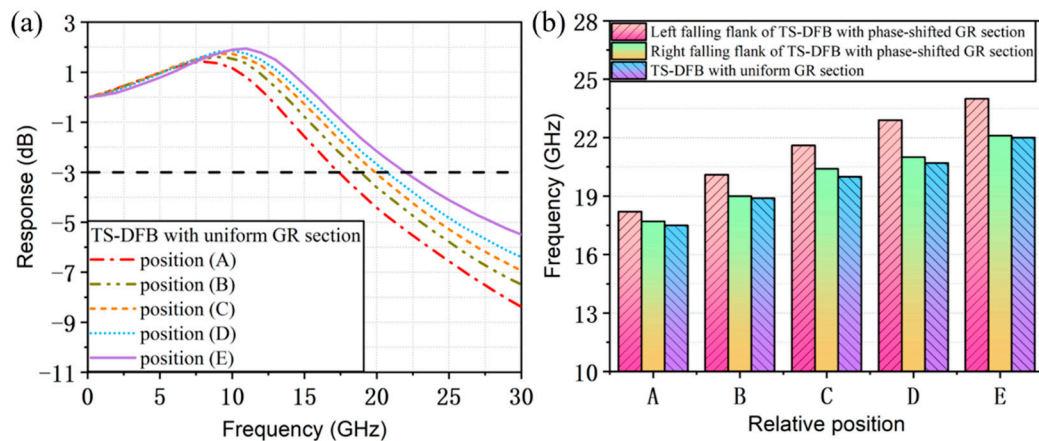


Figure 14. (a) Small signal intensity modulation response for different positions at the falling flank; (b) Comparison of 3-dB modulation bandwidth between the TS-DFB with and without phase-shift in GR section.

4. Conclusions

A novel high-speed directly modulated TS-DFB semiconductor laser based on REC technique is proposed and investigated. A π phase-shift is introduced into the reflection grating which can provide a narrow-band reflection region with a sharp falling slope on both sides of the reflection spectrum. As that the detuned-loading effect can be enhanced and utilized twice. The modulation bandwidth is increased from 17.5 GHz for single DFB laser to 24 GHz when the lasing wavelength is located on the left falling edge of the TS-DFB laser and can be increased to 22 GHz for the right falling edge based on detuned-loading effect. By performing NRZ modulation on the laser, we obtain clear eye diagrams at 25 Gb/s and 30 Gb/s. An eight-channel TS-DFB laser array at the wavelength around 1550 nm has been investigated. The lasing wavelength of the eight channels varies from 1547.7 nm to 1553.45 nm and the maximum SMSR of the lasers is 43 dB. According to the result of linear fitting, the minimum wavelength residual of 0.035 nm is achieved. Moreover, we have investigated the performance of TS-DFB lasers with uniform grating reflector for comparison. We find that the bandwidth improvement of the detuned-loading effect in the TS-DFB lasers with uniform grating reflector are far inferior to those with π phase-shift in the grating reflector. Besides, precise wavelength control is required to prevent the lasing wavelength shifting outside the falling flank of the reflection spectrum due to thermal effect which greatly increases the difficulty of fabrication.

The structure proposed has great reference value for fabricating high-speed modulated DFB semiconductor lasers and can provide inspiration for future chip designs.

Author Contributions: Conceptualization, methodology, software, original draft, writing—review and editing, Y.Z. and H.G.; formal analysis, literature research, G.M.; methodology, software, S.G. and T.F.;

conceptualization, methodology, writing—review and editing, funding acquisition, X.C. All authors have read and agreed to the published version of the manuscript.

Funding: This research was partially supported by the National Key R&D Program of China, grant number 2020YFB2205804, in part by National Natural Science Foundation of China, under Grants 62374092, in part by Natural Science Foundation of Jiangsu Province, grant number BK20200334.

Data Availability Statement: The data presented in this study are available on request from the corresponding author. The data are not publicly available due to confidentiality request.

Conflicts of Interest: The authors declare no conflict of interest.

References

1. Takiguchi, T.; Hanamaki, Y.; Kadowaki, T.; et al. High speed 1.3- μm AlGaInAs DFB-LD with $\lambda/4$ -shift grating. 2001 International Conference on Indium Phosphide and Related Materials, Nara, Japan, 14-18 May 2001.
2. Kobayashi, W.; Tadokoro, T.; Ito, T.; et al. High-speed operation at 50 Gb/s and 60-km SMF transmission with 1.3- μm InGaAlAs-based DML. ISLC 2012 International Semiconductor Laser Conference, California, USA, 7-10 Oct 2012.
3. Zhang, C.; Srinivasan, S.; Tang, Y.; et al. Low threshold and high speed short cavity distributed feedback hybrid silicon lasers. *Opt. Express* **2014**, *22*(9), 10202-10209.
4. Uomi, K.; Nakano, H.; et al. Ultrahigh-speed 1.55- μm $\lambda/4$ -shifted DFB PIQ-BH lasers with bandwidth of 17 GHz. *Electron. Lett.* **1989**, *10*(25), 668-669.
5. Matsuda, M.; Uetake, A.; Simoyama, T.; et al. 1.3- μm -Wavelength AlGaInAs Multiple-Quantum-Well Semi-Insulating Buried-Heterostructure Distributed-Reflector Laser Arrays on Semi-Insulating InP Substrate. *IEEE J Sel Top Quantum Electron* **2015**, *21*(6), 241-247.
6. Nakahara, K.; Wakayama, Y.; Kitatani, T.; et al. Direct Modulation at 56 and 50 Gb/s of 1.3- μm InGaAlAs Ridge-Shaped-BH DFB Lasers. *IEEE Photon. Technol. Lett.* **2015**, *27*(5), 534-536.
7. Oberg, M.; Kjebon, O.; Lourdudoss, S.; et al. Increased modulation bandwidth up to 20 GHz of a detuned-loaded DBR laser. *IEEE Photon. Technol. Lett.* **1994**, *6*(2), 161-163.
8. Kjebon, O.; Schatz, R.; et al. Experimental evaluation of detuned loading effects on distortion in edge emitting DBR lasers. 2002 International Topical Meeting on Microwave Photonics, Awaji, Japan, 5-8 Nov 2002.
9. Chaciński, M.; Schatz, R. Impact of Losses in the Bragg Section on the Dynamics of Detuned Loaded DBR Lasers. *IEEE J Quantum Electron* **2010**, *46*(9), 1360-1367.
10. Matsui, Y.; Schatz, R.; Carey, G.; et al. Direct modulation laser technology toward 50-GHz bandwidth. 2016 International Semiconductor Laser Conference, Kobe, Japan, 12-15 Sept 2016.
11. Xu, Y.; Gu, H.; Fang, T.; et al. Direct Modulation Bandwidth Improvement in Two-section DFB Lasers Based on the Detuned Loading Effect. 2022 Asia Communications and Photonics Conference, Shenzhen, China, 5-8 Nov 2022.
12. Mao, Y.; Ren, Z.; Zhang, R.; et al. Extending the direct modulation bandwidth by mutual injection locking in integrated coupled DFB lasers. 2017 IEEE Photonics Conference, Florida, USA, 1-5 Oct 2017.
13. Zhang, Y.; Li, L.; Zhou, Y.; et al. Modulation properties enhancement in a monolithic integrated two-section DFB laser utilizing side-mode injection locking method. *Opt. Express* **2017**, *25*(22), 27595-27608.
14. Zhao, W.; Mao, Y.; Lu, D.; et al. Modulation Bandwidth Enhancement of Monolithically Integrated Mutually Coupled Distributed Feedback Laser. *Appl. Sci.* **2020**, *10*(12), 4375.
15. Matsui, Yasuhiro et al. 55-GHz bandwidth short-cavity distributed reflector laser and its application to 112-Gb/s PAM-4. 2016 Optical Fiber Communications Conference and Exhibition, California, USA, 20-24 March 2016.
16. Yamaoka, S.; Diamantopoulos, N. P.; Nishi, H.; et al. 239.3-Gbit/s net rate PAM-4 transmission using directly modulated membrane lasers on high-thermal-conductivity SiC. 45th European Conference on Optical Communication, Dublin, Ireland, 22-26 Sept 2019.
17. Che, D.; Matsui, Y.; Schatz, R.; et al. 200-Gb/s Direct Modulation of a 50-GHz Class Laser With Advanced Digital Modulations. *J. Light. Technol.* **2021**, *39*(3), 845-852.
18. Sulikhah, S.; Tsao, H. W. Improvement on Direct Modulation Responses and Stability by Partially Corrugated Gratings Based DFB Lasers With Passive Feedback. *IEEE PHOTONICS J* **2021**, *13*(1), 1-14.
19. Lu, L.; Shi, Y.; Chen, X. Four channel DFB laser array based on the reconstruction-equivalent-chirp technique for 1.3 μm CWDM systems. 2013 Optical Fiber Communication Conference and Exposition and the National Fiber Optic Engineers Conference, California, USA, 17-21 March 2013.
20. Li, L.; Lu, L.; Li, S.; et al. Phase-shifted distributed feedback laser with linearly chirped grating fabricated by reconstruction equivalent chirp technique. *Opt Laser Technol* **2014**, *61*, 57-61.

21. B. S. Kim.; Y. Chung.; et al. An efficient split-step time-domain dynamic modeling of DFB/DBR laser diodes. *IEEE J. Quantum Electron* **2000**, 36, 787-794.
22. L. M. Zhang.; S. F. Yu.; M. C. Nowell.; et al. Dynamic analysis of radiation and side-mode suppression in a second-order DFB laser using time-domain large-signal traveling wave model. *IEEE J. Quantum Electron* **1994**, 30, 1389–1395.
23. Fernandes, C.A. Transfer matrix modelling in DFB lasers. *MICROELECTRON ENG* **1998**, 43, 553-560.
24. Morrison, Gordon and Daniel T. Cassidy. A probability-amplitude transfer matrix model for distributed-feedback laser structures. *IEEE J. Quantum Electron* **2000**, 36, 633-640.

Disclaimer/Publisher's Note: The statements, opinions and data contained in all publications are solely those of the individual author(s) and contributor(s) and not of MDPI and/or the editor(s). MDPI and/or the editor(s) disclaim responsibility for any injury to people or property resulting from any ideas, methods, instructions or products referred to in the content.